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CONFIRMATION NO. 3373

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APPLICANTS Chihiro Kawai, Itami-shi, Hyogo, JAPAN; Masami Tatsumi, Itami-shi, Hyogo, JAPAN;					
** CONTINUING DATA ***** This application is a 371 of PCT/JP03/08777 07/10/2003					
** FOREIGN APPLICATIONS ***** JAPAN 2002-202837 11/07/2002 JAPAN 2002-292533 10/04/2002 JAPAN 2002-321351 11/05/2002 JAPAN 2003-90727 03/28/2003 JAPAN 2003-148029 05/26/2003					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged Examiner's Signature _____ Initials _____		STATE OR COUNTRY JAPAN	SHEETS DRAWING 28	TOTAL CLAIMS 68	INDEPENDENT CLAIMS 4
ADDRESS McDermott Will & Emery 600 13th Street N W Washington ,DC 20005-3096					
TITLE Porous semiconductor and method for manufacturing same					
FILING FEE RECEIVED 2160	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		